



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroyuki NAGASAKA

Group Art Unit: 2882

Application No.: 10/589,962

Examiner: C. RIDDLE

Filed: August 18, 2006

Docket No.: 128675

For: EXPOSURE METHOD, EXPOSURE APPARATUS, EXPOSURE SYSTEM AND  
DEVICE MANUFACTURING METHOD

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the January 13, 2010 Office Action, the period for response being extended by the attached Petition for Extension of Time and in view of the June 8, 2010 personal interview, please consider the following:

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**